03500.014730.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Ap | oplication of: |) | Erraninan Nat Vat Aprianal | | |
|-------------------------------------|-------------------------|--------|----------------------------|--|--|
| HIROS | HI OHKURA ET AL. |) | Examiner: Not Yet Assigned | | |
| Div. of Application No.: 10/609,421 | | :) | Group Art Unit: 1756 | | |
| Filed: J | uly 1, 2003 |) | | | |
| For: | METHOD OF MANUFACTURING |) | November 19, 2003 | | |

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents enclosed.

The Examiner's attention is also directed to the following U.S. Application:

| APPLICATION NO. | FILING DATE | GROUP ART UNIT | | |
|-----------------|--------------------|-----------------------|--|--|
| 10/396,397 | 03/26/03 | 2812 | | |

A copy of this Application is enclosed.

The concise explanation of relevance for the non-English documents may be found, inter alia, where cited in the specification of the enclosed Application No.

10/396,397 and/or in the English language abstracts attached thereto. Also, the concise

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explanation of relevance for JP 10-121292 may be found in U.S. Patent No. 6,139,713,

which is in the same family as and JP 10-121292 and which is already of record in the

subject application.

As a formal matter, Applicants would like to point out that the concise

explanation of relevance for JP 7-171984, and not for JP 11-200090 as mentioned in the

Information Disclosure Statement filed on July 1, 2003, may be found in the English

translation, which was provided in the parent application.

CONCLUSION

It is respectfully requested that the above information be considered by the

Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such

information has been considered.

Applicants' undersigned attorney may be reached in our New York office by

telephone at (212) 218-2100. All correspondence should continue to be directed to our

address given below.

Respectfully submitted,

corney for Applicants

Registration No. 48,5/2

FITZPATRICK, CELLA, HARPER & SCINTO

30 Rockefeller Plaza

New York, New York 10112-3801

Facsimile: (212) 218-2200

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| FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE PECOLOGICAL CONTROL OF THE PATENT AND TRADEMARK OFFICE PECOLOGICAL CONTROL OF THE PATENT | | ATTY DOCKET NO. 03500.014730.1 APPLICATION NO. 10/609 | | TION NO. 10/609,4 | \$21 | | |
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| | (USE | | DA 5 U 5003 | FILING DATE July 1, 2003 | | GROUP | 756 |
| | | P. P. S. | | J.S. PATENT DOCUMENTS | | | |
| *EXAMINER INITIAL | | DOCUMENT NUMBER | OATE DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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| | | | FO | REIGN PATENT DOCUMENTS | | <u> </u> | - |
| | | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION YES/NO/ OR ABSTRACT |
| | JP | 2000-195036 | 07/14/00 | Japan | | | Abstract |
| | JP | 10-121292 | 05/12/98 | Japan | | | Abstract |
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| | OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | |
| | Hideki Masuda et al., "Fabrication of Gold Nanodot Array Using Anodic Porous Alumina as an Evaporation Mask," 35 <u>Jpn. J. Appl. Phys.</u> L126-L129 (1996). | | | | | | |
| | O. Jessensky et al., "Self-Organized Formation of Hexagonal Pore Arrays in Anodic Alumina," 72(10) Appl. Phys. Lett. 1173-1175 (March 1998). | | | | | | |
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| EXAMINER | | | | DATE CONSIDERED | | | |

| Sheet | 1 | of | 1 |
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.